

Docket No.: 04110/0201116-US0  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:  
Yoshi ISHII et al.

Application No.: 10/813,558

Confirmation No. 4103

Filed: March 29, 2004

Art Unit: 3746

For: VACUUM CONTROL SYSTEM

Examiner: L. J. Weinstein

**PRELIMINARY AMENDMENT**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

## INTRODUCTORY COMMENTS

Prior to examination on the merits, please amend the above-identified U.S. patent application as follows.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.